Commissioner for Patents United States Patent and Trademark Office Washington, D.C. 2020

Paper No.

Date

: January 29, 2001

TO

Director, Office of Publication and Dissemination

**FROM** 

Office of the Deputy Commissioner

for Patent Examination Policy

SUBJECT

Withdrawal from Issue of

Applicant(s)

: Toshiro Akira

Application No.

: 09/159,968

Filed

: September 24, 1998

The above-identified application has been assigned Patent No. 6,181,986 and an issue date of January 30, 2001.

It is hereby directed that this application be withdrawn from issue at the request of the applicant.

Do not refund the issue fee.

The following erratum should be published in the Official Gazette if the above-identified application is published in the OG of January 30, 2001:

"All reference to Patent No. 6,181,986 to Toshiro Akira of Wakayama-Shi, Japan for METHOD OF CORRECTING TRANSFER OF A THIN MATERIAL AND A THIN MATERIAL TRANSFER APPARATUS appearing in the Official Gazette of January 30, 2001 should be deleted since no patent was granted."

Marianne E. Morgan/ Petitions Examiner Office of Petitions

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Office of Petitions
Office of the Deputy Commissioner
for Patent Examination Policy

cc: Geraldine Dozier, Crystal Park 3-441 (FAX-306-2737) Deneise Boyd, Crystal Park 2, Suite 1100 (FAX-308-5413) Mary Louise McAskill, Crystal Park 3-910 (FAX 305-4372) Niomi Farmer, Crystal Park 3-910 (FAX-305-4372) Janet Higgins, Crystal Park 3-910 (FAX-305-4372) Mary E. Johnson (Cookie), P/OCS, CM1-6D07 Duane K.Davis, P/OCS, CM1-6A07